

## <u>IN THE UNITED STATES PATENT AND TRADEMARK OFFICE</u>

ICANT:

Jeong-Hyun Oh

Atty. Docket No: 5000-1-185

SERIAL NO.:

09/750,510

EXAMINER: Not yet assigned

FILED

December 28, 2000

ART UNIT

: Not yet assigned

**FOR** 

METHOD FOR FABRICATING HIGH-PURITY SILICA

GLASS USING SOL-GEL PROCESSING

## Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to ASSISTANT COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231 on September 25, 2002.

Steve Cha, Reg. No. 44,069 (Name of Registered Rep.)

Signature and Date)

## TRANSMITTAL OF REVOCATION AND APPOINTMENT OF ATTORNEYS

ASSISTANT COMMISSIONER FOR PATENTS WASHINGTON, D.C. 20231

Dear Sir:

The undersigned, as an Applicant and owner hereof, hereby revokes all powers previously granted and appoints

Steve S. Cha

Registration No. 44,069

of CHA & REITER, 411 Hackensack Ave, 9th floor, Hackensack, New Jersey 07601, as new attorney with full power of substitution and revocation, to prosecute the above application, to make alterations and amendments therein, to receive the patent, and to transact all business in the Patent and Trademark Office connected herewith.

CEIVEL CEIVEL



Creation date: 19-06-2003

Indexing Officer: KLITTLE - KEVIN LITTLE Team: FILING RCPT CORRECTIONS

Dossier: 09750510

Legal Date: 22-10-2002

No.	Doccode	Number of pages
1	CTMS	2

Total number of pages: 2

Remarks:

Order of re-scan issued on .....

D----